FORM PTO-1449		US Dept. of Co		ATTORNEY DOCKET NO.		SERIAL NO.		
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				APPLICANT				
INFORMATION DISCOSURE STATEMENT				Xueping Xu, et al.				
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U.S. PATENT DOCUMENTS EXAMINER CONTROL FILIN								DATE
INITIAL	9	PADENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	SUBCLASS FILING DATE IF APPROPRIATE	
222	AA	5,637,531	6/10/1997	Porowski, et al.				
555	AB	6,455,877	9/24/2002	Ogawa, et al.				
535	AC	2001/0030329	10/18/2001	Ueta, et al.				
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSL YES	ATION NO
							X (abstract only)	
OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)								
555	AD	S. Porowski, et al., J. Cryst. Growth, Vol. 178, 174 (1997)						
222	AE	M. Bockowski, J. Cryst. Growth, Vol. 246, 194 (2002)						
535	AF	F.A. Ponce, et al. Appl. Phys. Lett., 68(1), 57 (1996)						
SSS	AG	E. Frayssington, et al., Appl. Phys. Lett. 77, 2551 (2000)						
2.28	AH	M. Kamp, et al., MRS Internet J. Nitride Semicond. Res. 4S1, G.10.2 (1999)						
222	ΑI	A.R.A. Zauner, et al., Crystal Growth, 210, 435 (2000)						
855	AJ	S. Nakamura, et al., Jpn. J. Appl. Phys. 37, L309 (1998).						
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